Docket No.: 61352-041

PATENT

TES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Hiroyuki FURUYA, et al.

Confirmation Number: 2093

Serial No.: 10/620,432

Group Art Unit: 2812

Filed: July 17, 2003

Examiner:

For:

METHOD OF FABRICATING NITRIDE BASED SEMICONDUCTOR SUBSTRATE AND METHOD OF FABRICATING NITRIDE BASED SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEME

Mail Stop Missing Parts Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

10/620,432

Each non-English language reference was first cited in a corresponding foreign

application search report or office action. A copy of the foreign search report or office action,

together is attached for the Examiner's information.

The relevance of "InGaN/GaN/A1GaN-based laser diodes grown on epitaxially laterally

overgrown GaN" and "High-Power; Long-Lifetime InGaN/GaN/A1GaN-Based Laser Diodes

Grown on Pure GaN Substrates" is discussed on pages 3 and 4 of the present specification.

Please charge any shortage in fees due in connection with the filing of this paper, including

extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit

account.

Respectfully submitted,

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Date: December 18, 2003

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INFORMATION DISCLOSURE				ATTY. DOCKET NO.	SERIAL NO)		
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APPLICATION								
				APPLICANT				
				Hiroyuki FURUYA, et al.				
(PTO-1449)				FILING DATE July 17, 2003	GROUP 2812	GROUP 2812		
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EXAMINER'S	Г	Foreign Patent Document	Publication Date	e a Constantina de la Constantina del Constantina de la Constantin	Pages, Columns, Lines		anslation	
INITIALS	CITE NO.	Country Codes -Number 4 -Kind Codes (if known)	MM-DD-YYYY	Applicant of Cited Document	Where Relevant Figures Appear	`		
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	Ц	KR 2010583 A	S T (11	Copy not enclosed.		<u> </u>		
EXAMINER'S		OTHER AF	RI (Including Autho	or, Title, Date, Pertinent Pages, E	tc.)			
INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.						
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EXAMINER				DATE CONSIDERED				

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.